

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takatomo YAMAGUCHI et al.

Application No.: New U.S. National Stage of

PCT/JP2004/017723

Filed: April 4, 2006 Docket No.: 127569

For: SUBSTRATE PROCESSING APPARATUS, SUBSTRATE HOLDER, AND

MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. Relevance of one or more non-English language reference is discussed in the present specification. See Reference 2.
- 3. One or more reference cited herein was cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information. See References 3-7.
- 4. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- 5. An English language Abstract of one or more non-English language reference is attached hereto. See References <u>2-7</u>.

New U.S. National Stage of PCT/JP2004/017723

IAP9 Rec'dPCT/PTO 04 APR 2006

- 6. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See References 2-3 & 5-7.
- 7. Reference 1 corresponds to reference

Respectfully submitted,

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JAO:JSA/crh

Date: April 4, 2006

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE
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Sheet 1 of 1

Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 127569			APPLICATION NO. New U.S. National Stage of	
INFORMATION DISCLOSURE STATEMENT							PCT/JP200)4/017723
(Use several sheets if necessary)				APPLICANTS Takatomo YAMAGUCHI et al.				
				FILING DATE April 4, 2006				
U.S. PATENT DOCUMENTS								
Examiner Initials	Cite No.	Document Number	Date			Name		
	1	5,743,967	04/28/1998		KOBORI et al.			
FOREIGN PATENT DOCUMENTS								
Examiner Initials	Cite No.	Document Number	Da	ite	Country		With English Abstract	With English Translation
	2	JP A 11-40509	02/12/1999		JAPAN		Х	х
	3	JP A 9-92623	04/04/1997		JAPAN		х	х
	4	JP A 4-2118	01/07/19	92	JAPAN		х	
	5	JP A 2001-168175	06/22/20	001	JAPAN		х	х
	6	JP A 10-233368	09/02/19	98	JAPAN		х	х
	7	JP A 10-41236	02/13/19	98	JAPAN		х	х
OTHER DOCUMENTS								
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)						
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EXAMINER						DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

Date: April 4, 2006